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**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1795  
PATENT**

Attorney Docket No. 04329.3304-00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)
	)
Ayako NAKANO et al.	) Group Art Unit: 1795
	)
Application No.: 10/823,539	) Examiner: Stephen D. ROSASCO
	)
Filed: April 14, 2004	) Confirmation No.: 4440
	)
For: PATTERN FORMING METHOD AND	)
SYSTEM, AND METHOD OF	)
MANUFACTURING A	)
SEMICONDUCTOR DEVICE	)

**Mail Stop AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION**

In reply to the final Office Action mailed November 6, 2007, the period for response to which extends through February 6, 2008, Applicants respectfully request reconsideration of the above-identified application in light of the following remarks.